

INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

0EKM-104599

Application Number

10/634,023

Applicant(s)

Drew T. De Shiell, et al.

Filing Date

August 4, 2003

Group Art Unit

3711

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SP	5,328,176	07/12/1994	Lo	273	167	06/10/1993
SP	5,410,798	05/02/1995	Lo	29	527	01/06/1994
SP	5,425,538	06/20/1995	Vincent, et al.	273	167	11/04/1991
SP	5,624,331	04/29/1997	Lo, et al.	473	345	10/30/1995
SP	US 6,299,547 B1	10/09/2001	Kosmatka	473	329	12/30/1999
SP	US 2001/0049310 A1	12/06/2001	Cheng, et al.	473	334	03/28/2001
SP	US 6,334,817 B1	01/01/2002	Ezawa, et al.	473	324	12/29/1999
SP	US 2002/0022535 A1	02/21/2002	Takeda	473	346	06/28/2001
SP	US 2002/0142859 A1	10/03/2002	Galloway, et al.	473	329	04/22/2002
SP	US 2003/0032500 A1	02/13/2003	Nakahara, et al.	473	345	08/01/2002

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
SP		2002-165902	11/06/2002	Japan			✓	
SP		05-317465	03/12/1993	Japan			✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

S. Paravanti

DATE CONSIDERED

12-23-04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Document Number (Optional) 0EKM-104599		Application Number 10/634,023	
				Applicant(s) Drew T. DeShiel et al.			
				Filing Date 08/04/2003		Group Art Unit 3711	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SP		US 2003/0032500 A1	02/13/2003	Nakahara et al.	473	345	
SP		US 2003/0083151 A1	05/01/2003	Nakahara et al.	473	345	
SP		US 2003/0125127 A1	07/03/2003	Nakahara et al.	473	329	
SP		US 2003/0134693 A1	07/17/2003	Nakahara et al.	473	345	
FOREIGN PATENT DOCUMENTS							
	REV.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
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